

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AF
CN

Applicant: Mohan Chandra et al.

Title: DEVICE AND METHOD FOR MULTICRYSTALLINE SILICON WAFERS

Docket No.: 884.B40US1

Filed: October 24, 2003

Examiner: G. Nagesh Rao



Serial No.: 10/692,611

Due Date: November 6, 2006

Group Art Unit: 1722

MS AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

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☒ Amendment and Response under 37 CFR 1.116 (11 pgs.).

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SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

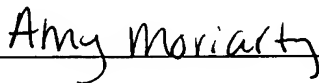
By: 

Atty: David C. Peterson

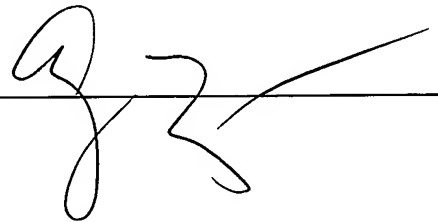
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Signature



SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)



EXPEDITED PROCEDURE – EXAMINING GROUP 1722

S/N 10/692,611

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Mohan Chandra et al.	Examiner:	G. Nagesh Rao
Serial No.:	10/692,611	Group Art Unit:	1722
Filed:	October 24, 2003	Docket No.:	884.B40US1
Title:	DEVICE AND METHOD FOR MULTICRYSTALLINE SILICON WAFERS		
Assignee:	Intel Corporation	Customer Number:	21186

AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Final Office Action mailed September 6, 2006, Applicant proposes an amendment to the application as follows: